IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hidekazu SATO, et al.

Serial Number: Not Yet Assigned

Filed: September 22, 2003

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 22, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

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DWH/jaz Atty. Docket No. **031179** Suite 1000 1725 K Street, N.W. Washington, D.C. 20006 (202) 659-2930

PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (3)

INFORMATION			Atty. Docket No. 031179				Serial No. New Application		
DISCLOSURE STATEMENT PTO-1449			Applicant(s): Hidekazu SATO, et al.						
		Filing Date: September 22, 2003			Group Art Unit: Not Yet Assigned				
U.S. PATENT DOCUMENTS									
Examiner Initial		Docum	ent No. Name			Date	Class	Subclass	Filing Date (If appropriate)
	AA								
	AB								
	AC								
	AD								
FOREIGN PATENT DOCUMENTS									
		Docum	ment No. Date			ountry		Translation (Yes or No)	
	AE		-						
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OTHER DOCUMENTS									
	AJ Patent Abstracts of Japan, Publication No. 5-062991, dated March 12, 1993. AK Patent Abstracts of Japan, Publication No. 10-125691, dated May 15, 1998. AL Patent Abstracts of Japan, Publication No. 11-126781, dated May 11, 1999.								
Examiner Date Considered									